



Electronic Filing System (EFS) Data
Electronic Patent Application Submission
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Hayes

EFS ID: 40967
Application ID: 09891611
Title of Invention: Inspection System By Charged
Particle Bean And Method Of
Manufacturing Devices Using
The System
First Named Inventor: Mamoru Makasuji
Domestic/Foreign Application: Domestic Application
Filing Date: 2001-06-27
Effective Receipt Date: 2003-05-23
Submission Type: Information Disclosure
Statement
Filing Type:
Confirmation number: 8874
Attorney Docket Number: 010817



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Total Fees Authorized:

Digital Certificate Holder: cn=William Lee Brooks,ou=Registered Attorneys,ou=Patent and
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ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

Title of Invention	Inspection System By Charged Particle Beam And Method Of Manufacturing Devices Using The System																				
<p>Application Number: 09/891611 Confirmation Number: 8874 First Named Applicant: Mamoru Makasuji Attorney Docket Number: 010817 Art Unit: 2881 Examiner: Jack I Berman Search string: (5578821).pn.</p> <p>US Patent Documents</p> <p>Note: Applicant is not required to submit a paper copy of cited US Patent Documents</p> <table border="1"><thead><tr><th>init</th><th>Cite.No.</th><th>Patent No.</th><th>Date</th><th>Patentee</th><th>Kind</th><th>Class</th><th>Subclass</th></tr></thead><tbody><tr><td></td><td>1</td><td>5578821</td><td>1996-11-26</td><td>Meisberger et al</td><td></td><td>250</td><td>310</td></tr></tbody></table> <p>Signature</p> <table border="1"><thead><tr><th>Examiner Name</th><th>Date</th></tr></thead><tbody><tr><td></td><td></td></tr></tbody></table>		init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass		1	5578821	1996-11-26	Meisberger et al		250	310	Examiner Name	Date		
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	1	5578821	1996-11-26	Meisberger et al		250	310														
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Electronic Version v1.1
Stylesheet Version v1.1.0

Title of Invention	Inspection System By Charged Particle Beam And Method Of Manufacturing Devices Using The System									
<p>Application Number: 09/891611 Date: 2001-06-27 First Named Applicant: Mr. Mamoru</p> <p>Confirmation Number: 8874 Attorney Docket Number: 010817</p>										
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<table border="1"><thead><tr><th>Submitted by:</th><th>Elec. Sign.</th><th>Sign. Capacity</th></tr></thead><tbody><tr><td>Mr. William L Brooks Registered Number: 34129</td><td>/WLB/</td><td>Attorney</td></tr></tbody></table>			Submitted by:	Elec. Sign.	Sign. Capacity	Mr. William L Brooks Registered Number: 34129	/WLB/	Attorney		
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Comments										

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